



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Cyril Cabral, Jr., et al.

Docket: YOR920030218US1 (16714)

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For: REDUCTION OF SILICIDE FORMATION TEMPERATURE ON SiGe CONTAINING SUBSTRATES

Commissioner for Patents
P.O. Box 1450
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REQUEST FOR CHANGE OF MAILING ADDRESS

Sir:

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